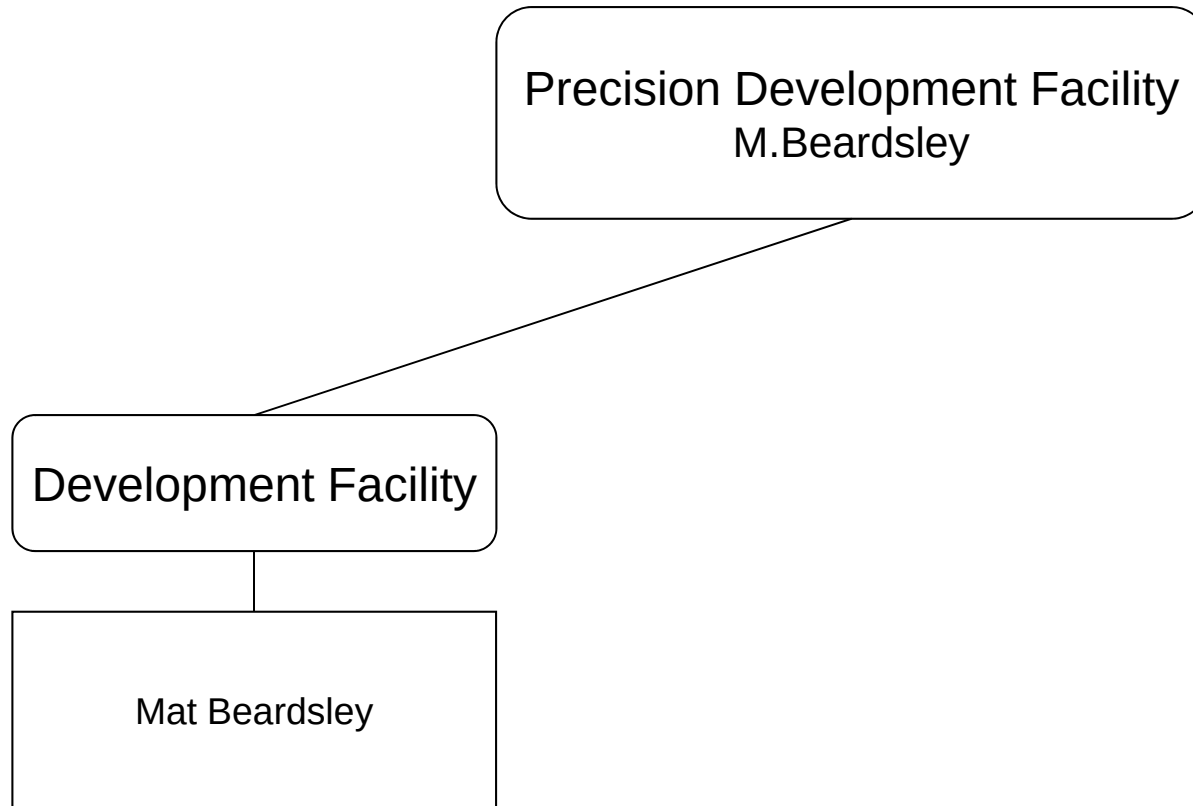


Manufacture of Precision Novel Geometries for Laser Science

M.Beardsley



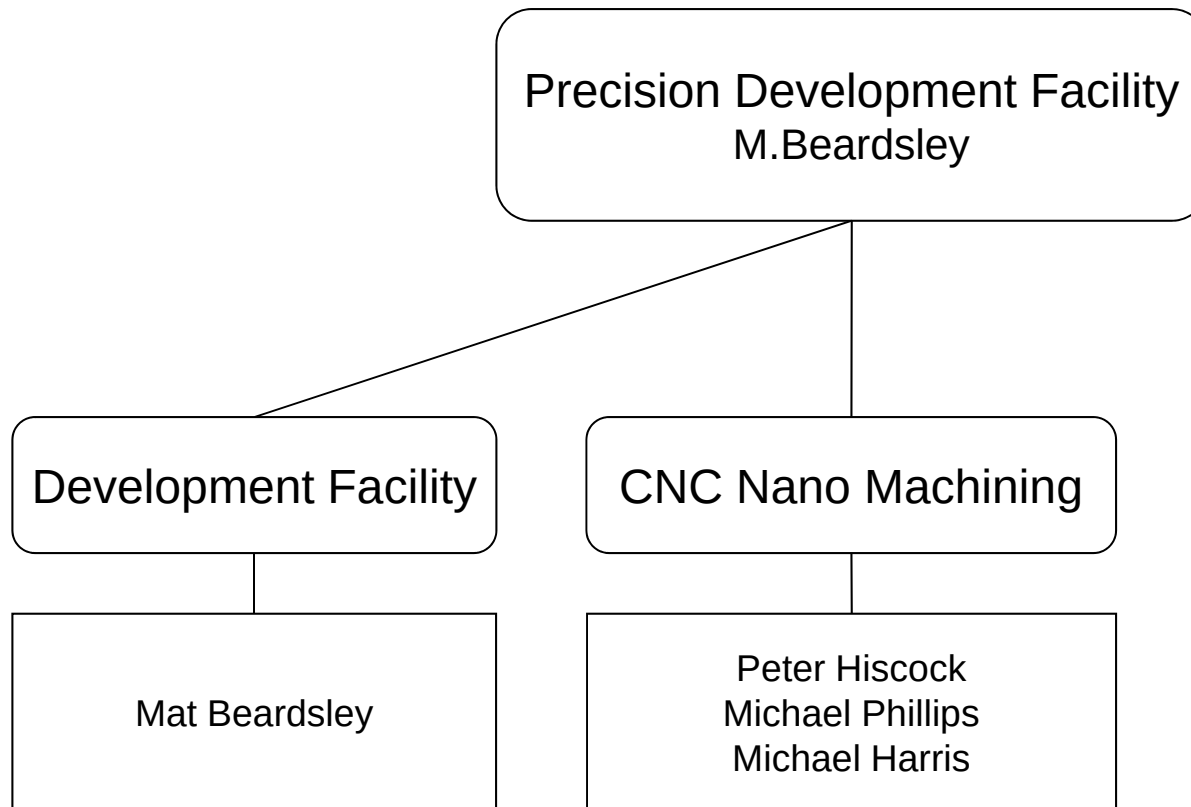
PDF Organagram



Development Facility



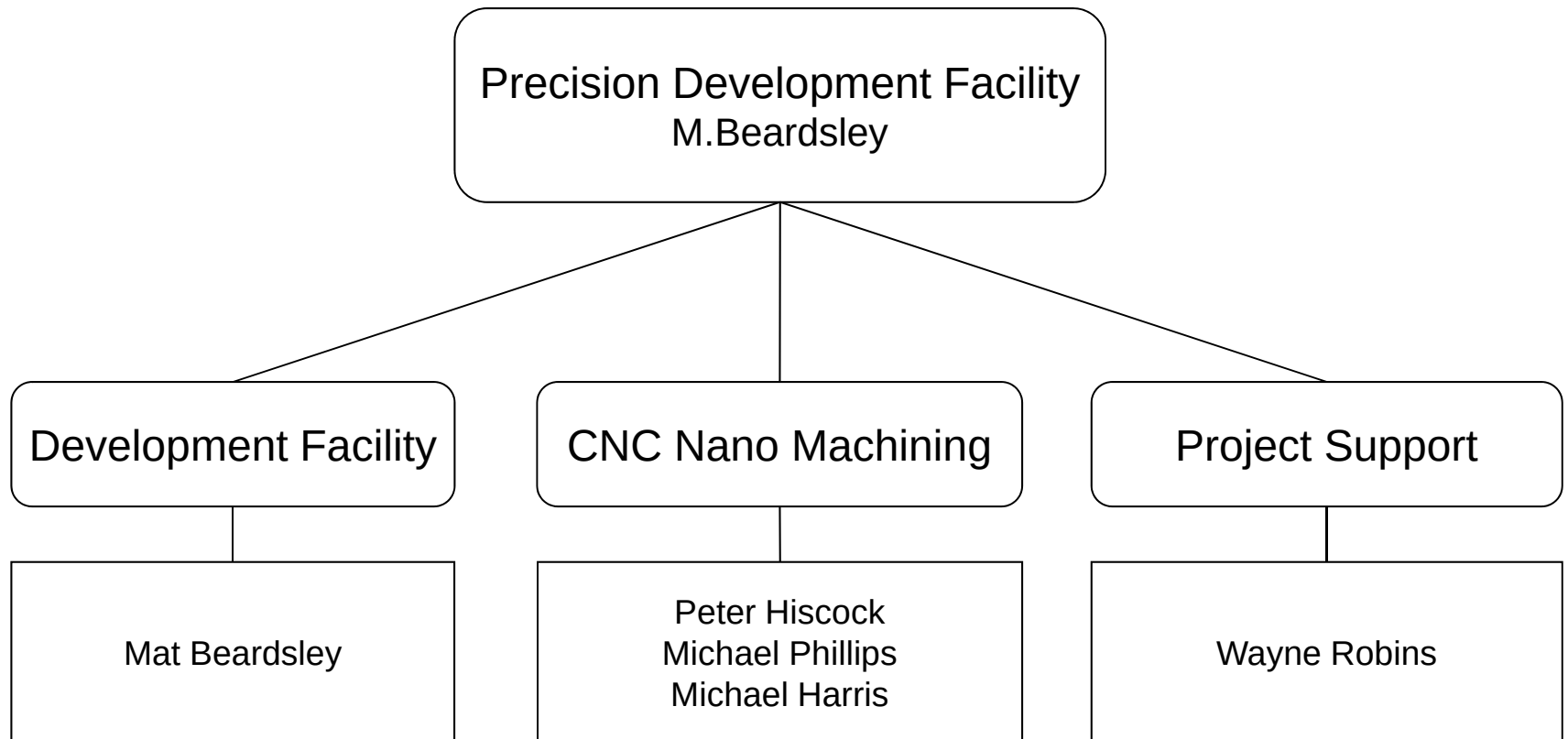
PDF Organagram



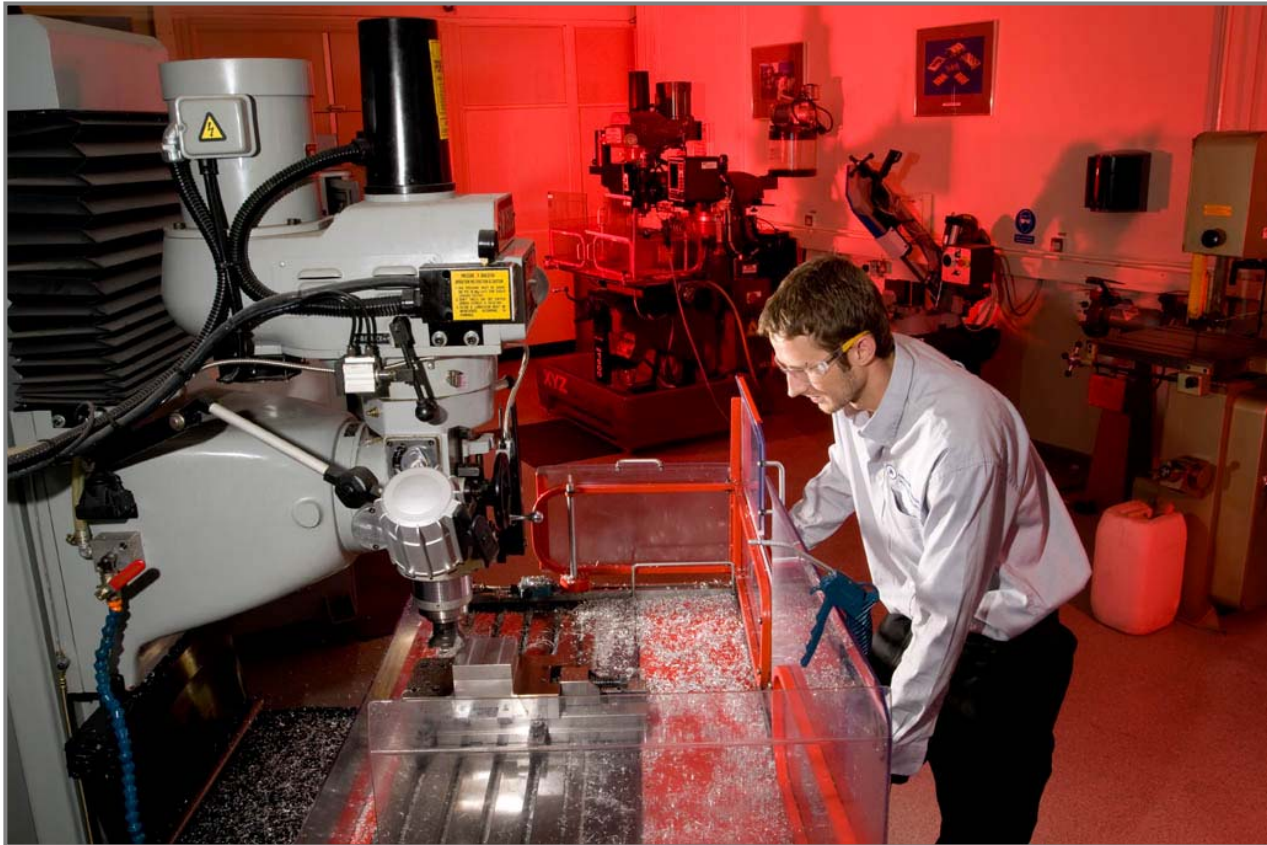
CNC Nano Machining



PDF Organagram



Project Support



Objectives of the Facility

- **Primarily developing and manufacturing devices operating in the microwave frequency range.**
- **Close support role for other Departments at the Rutherford Laboratory and commercial companies**
Laser, ISIS, OXSENSIS, QinetiQ

Development of novel machining techniques.
Production of miniature components

Target Manufacture

Example Geometries

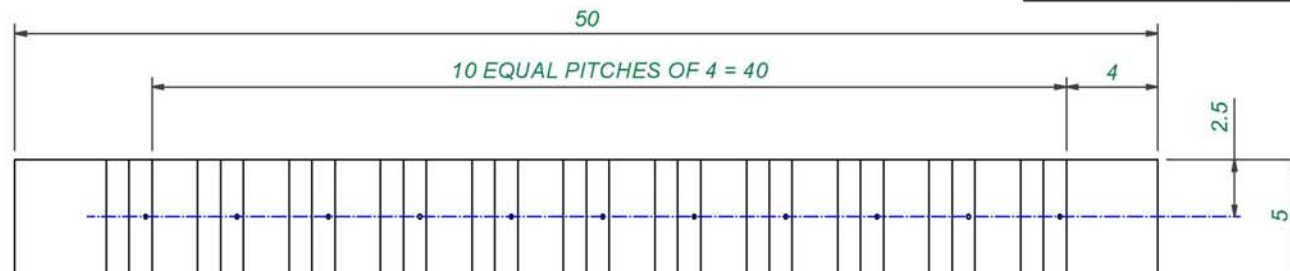
- Foam and Dimple – 200 micron dimple
- Free Standing Tapered Wire – 100 micron tapering to tip of 50 micron
- Iron Staircase – 10 micron step heights

A3 SL-4510-143-00

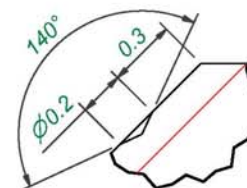
PROJECTION



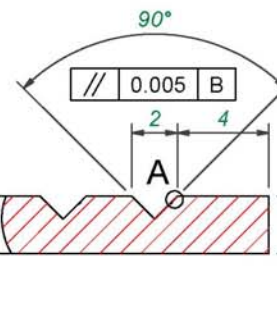
THIS DRAWING CONFORMS TO B.S.8888



ISOMETRIC VIEW
SCALE 1:1



DETAIL A (50 : 1)
TYP 11 POSITIONS



A3 SL-4510-143-00

A	30/04/2007		GJ	GJ		
ISSUE	DATE	MODIFICATION DESCRIPTION	DRN.	CHKD.	APPD.	STATUS
USED ON SL-4510-137-00				©CCLRC 2005		
C.C.L.R.C.-RUTHERFORD APPLETON LAB. OX11-0QX						
TITLE						
TARGET 45 DEGREE DIMPLED						
A3	SL-4510-143-00				REV	A

TOLERANCE UNLESS STATED

± 0.1

FINISH

CLEAN

REMOVE ALL BURRS

SURFACE FINISH μm

1.6

UNLESS STATED

ORIGINAL SCALE

5:1

DO NOT SCALE



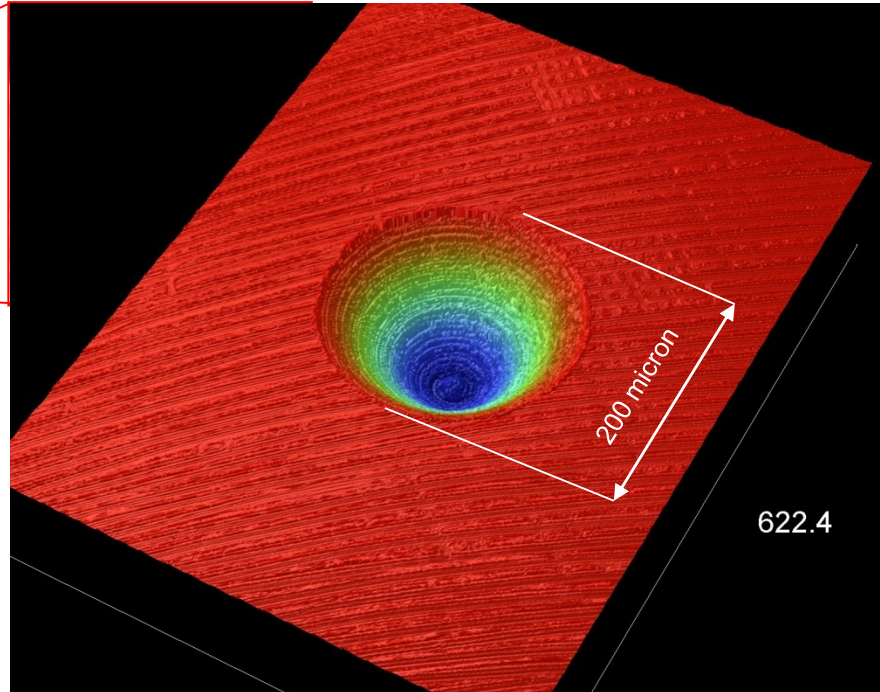
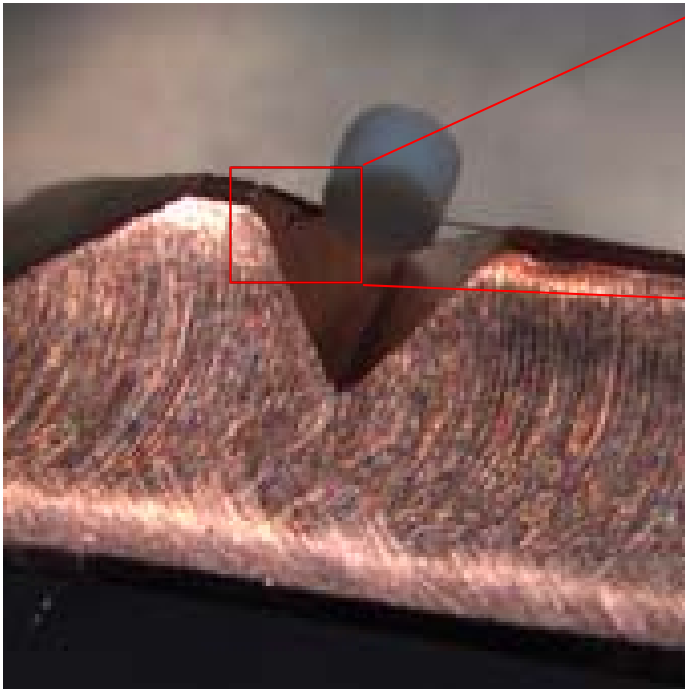
MATERIAL & SPEC.
AL ALLOY TO
BS1470/6082/0

Foam and dimple

Dimple machined on an angular face 35 microns deep

Material: Copper

Machine: Manual Precision Micro Mill

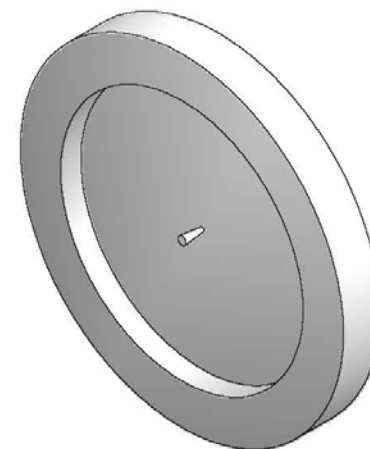
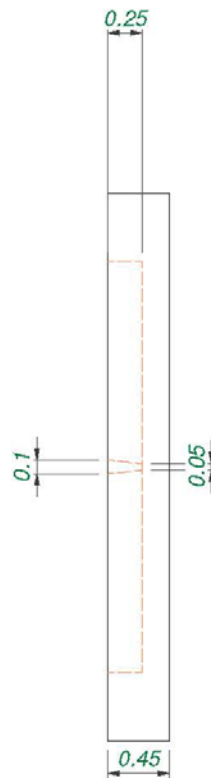
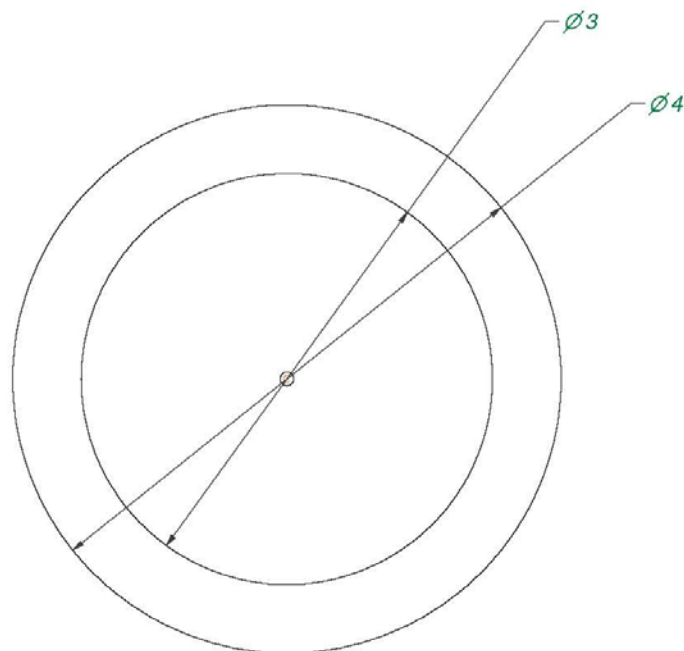


A3 TAP-0708-0002

PROJECTION



THIS DRAWING CONFORMS TO B.S.8888



A3 TAP-0708-0002

TOLERANCE UNLESS STATED

 ± 0.1

FINISH

CLEAN

REMOVE ALL BURRS

SURFACE FINISH μm

1.6

UNLESS STATED

ORIGINAL SCALE

DO NOT SCALE

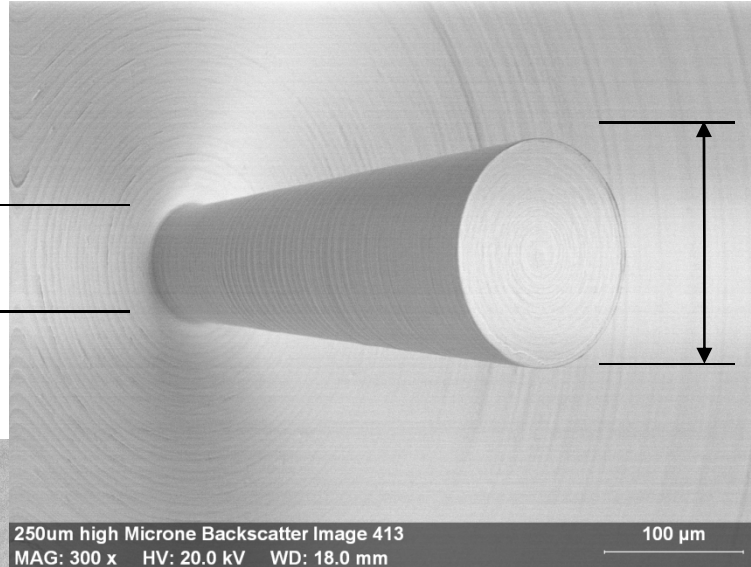
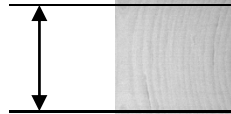
0

mm

A	07/07/2008		CS			
ISSUE	DATE	MODIFICATION DESCRIPTION	DRN.	CHKD.	APPD.	STATUS
USED ON				©STFC 2008		
S.T.F.C. - RUTHERFORD APPLETON LAB. OX11-0QX						
TITLE						
Embedded Cone						
A3	TAP-0708-0002					REV

Free Standing Wire - 250 micron

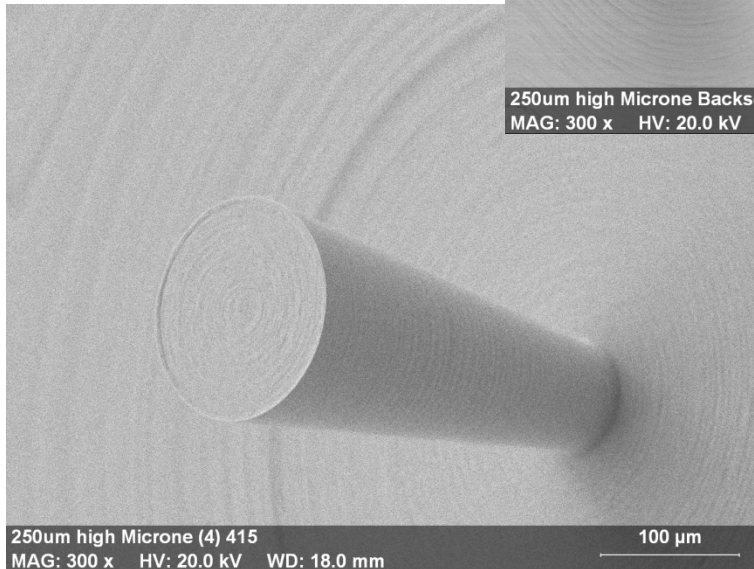
50 micron



100 micron

250um high Microne Backscatter Image 413
MAG: 300 x HV: 20.0 kV WD: 18.0 mm

100 µm

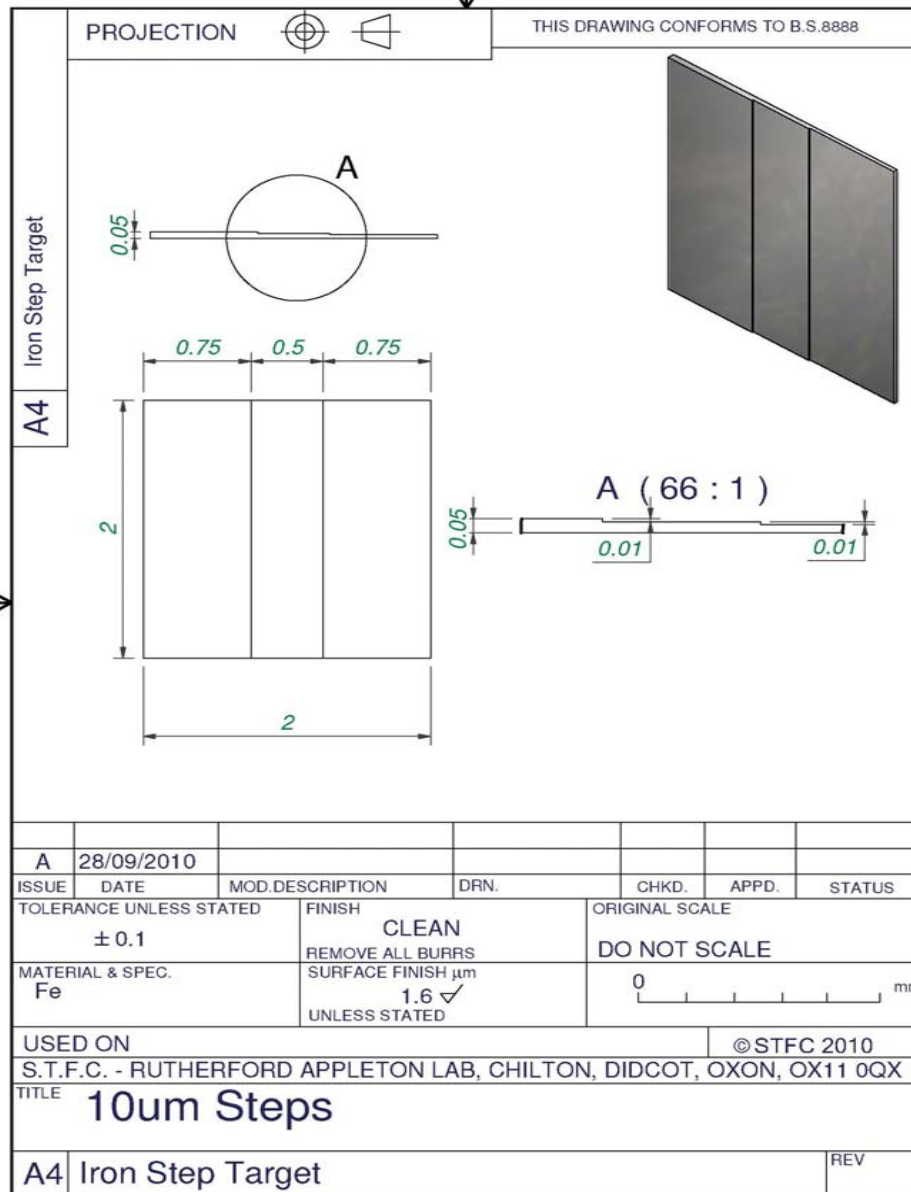


250um high Microne (4) 415
MAG: 300 x HV: 20.0 kV WD: 18.0 mm

100 µm

Material: Iron

Machine: Manual Hardinge Lathe



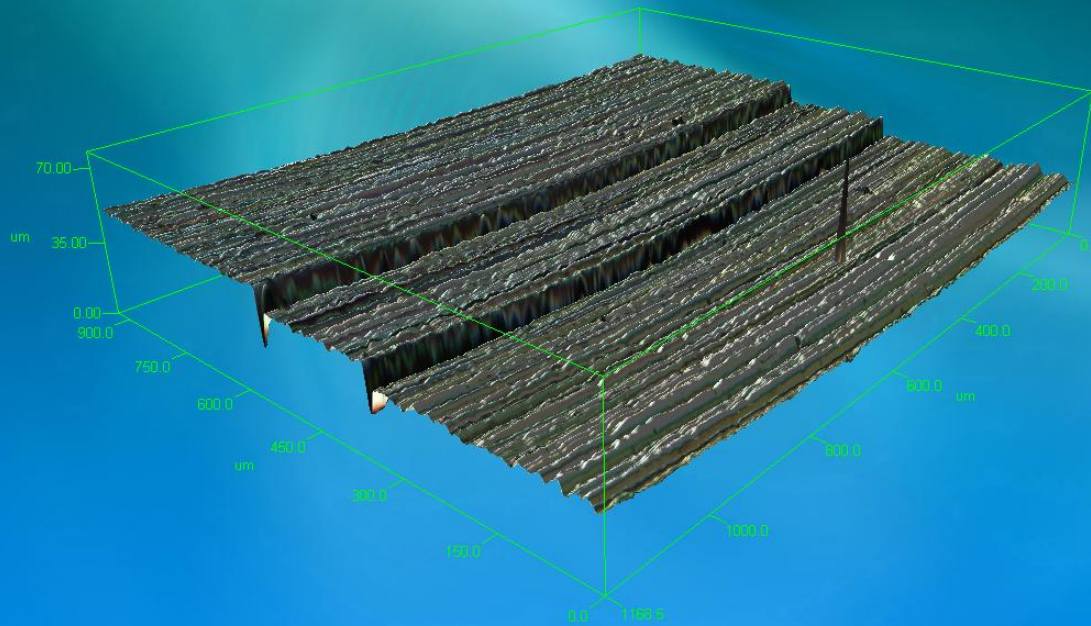
Material: Iron

Machine: SIXIS Jig Borer

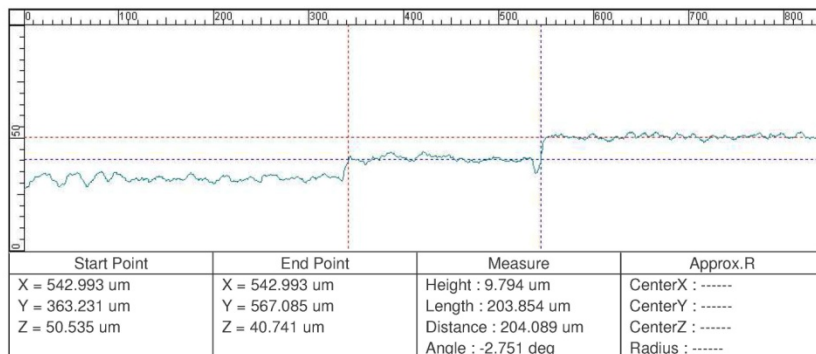
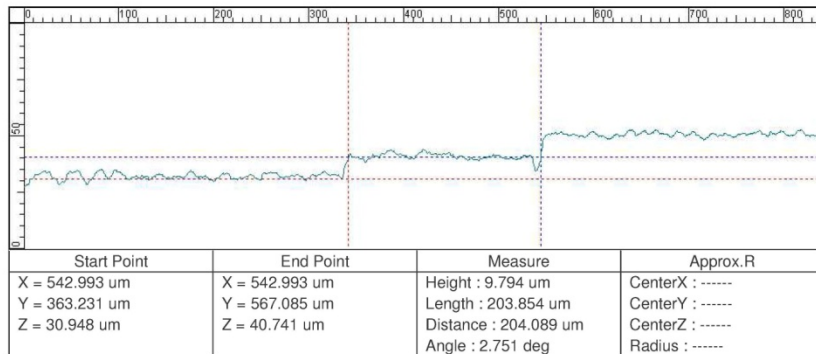
Machined using
unconventional machine
techniques unique to the PDF
to achieve high levels of
surface finish and accurate
step heights

Step Targets

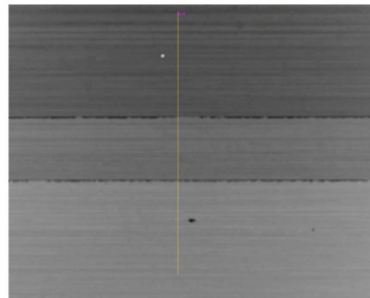
Mapped surface of iron stepped target



Gabriel Step Target 10, 20, 30um Steps



Step height
measurements



Title:
Note:

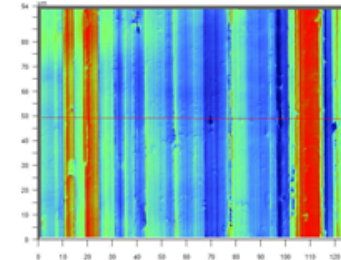
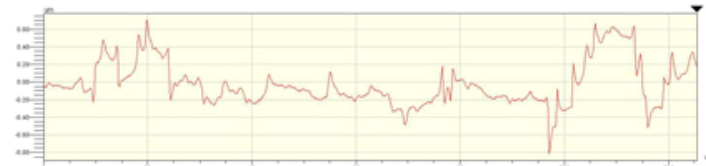
Date: 06/28/2010

Time: 14:20:30

Measurement Mode: VSI

Magnification: 50.27

2 Point Profile



UserNote1:

UserNote2:

UserNote3:

Rq	0.25 um
Ra	0.19 um
Rt	1.52 um
Rp	0.70 um
Rv	-0.82 um

Surface roughness
measurements typically
0.19 Ra

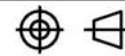
Target Manufacture

Complex Cones & Mass manufacture

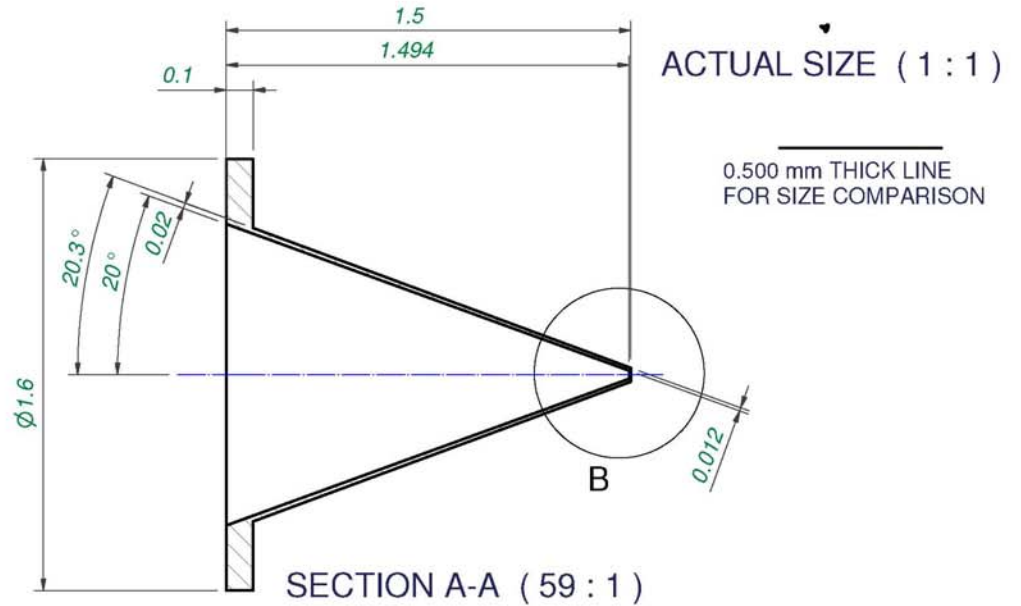
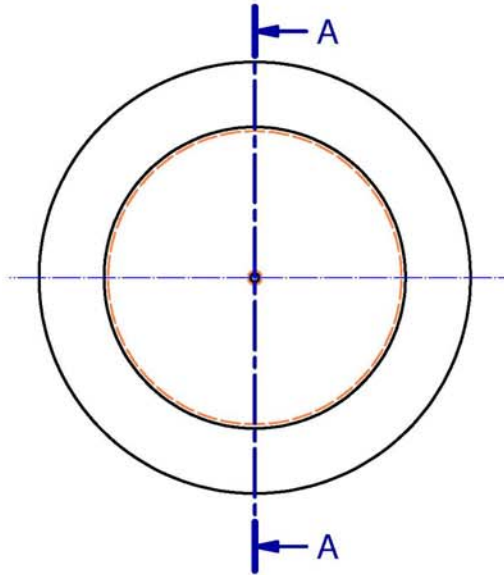
- Carried out feasibility on KERN Micro
- Enhanced the development on KERN Pyramid Nano
- Demonstrating mass manufacture of cones

A3 SL-3000-472-00

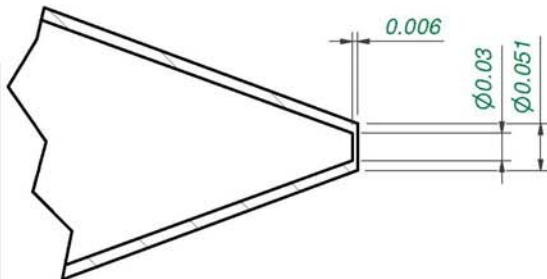
PROJECTION



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ISO VIEW (10 : 1)

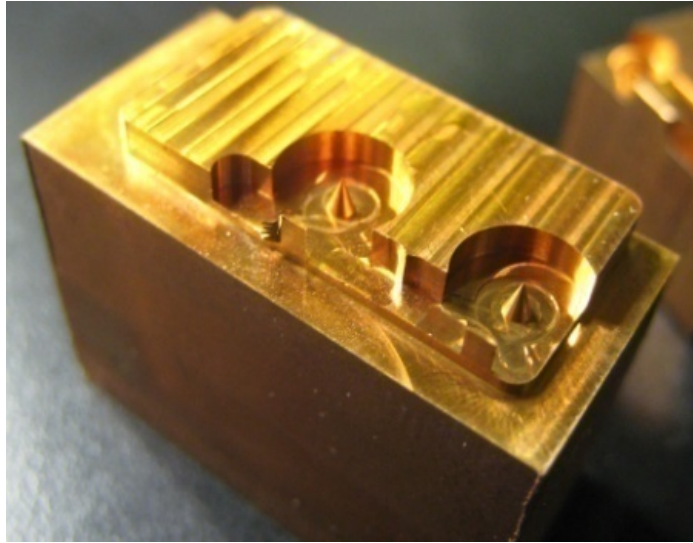


DETAIL B (200 : 1)

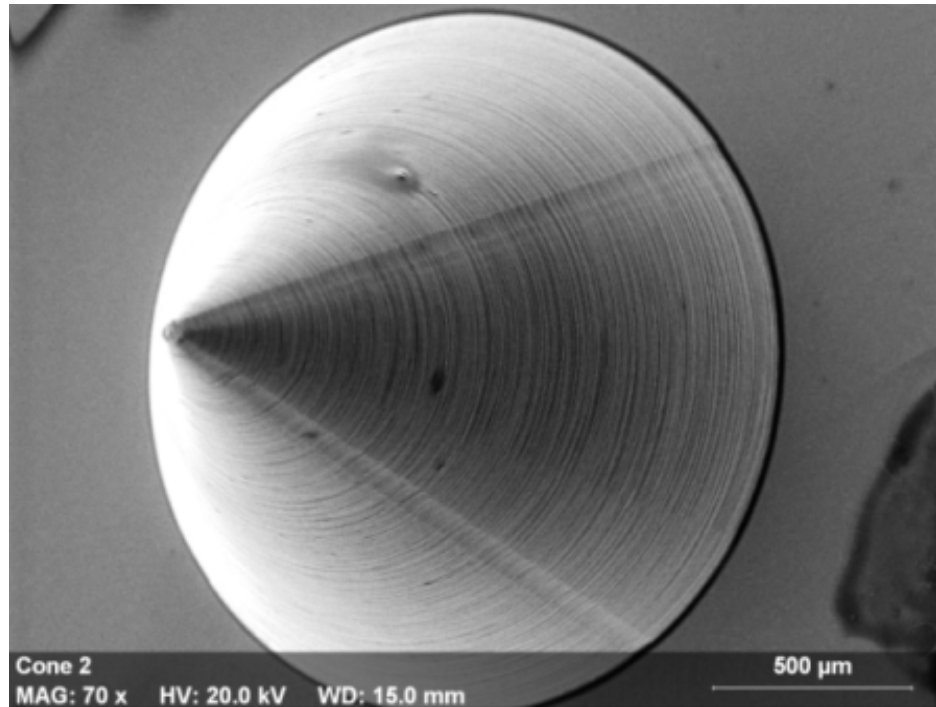
A	19.10.04		PB	PB		
ISSUE	DATE	MODIFICATION DESCRIPTION	DRN.	CHKD.	APPD.	STATUS
USED ON SL-3000-470-00				©CCLRC 2000		
C.C.L.R.C.-RUTHERFORD APPLETON LAB. OX11-0QX						
TITLE						
GOLD CONE TARGET (FLAT END)						
A3	SL-3000-472-00					REV A

TOLERANCE UNLESS STATED	FINISH	ORIGINAL SCALE
± 0.001	CLEAN REMOVE ALL BURRS	1:1 DO NOT SCALE
MATERIAL & SPEC.	SURFACE FINISH μm	0 50 mm
GOLD	3.2 ✓ UNLESS STATED	

CNC Milling Feasibility



First samples machined on
KERN Micro



Evidence of cutter dwell marks



3-Dimensional Interactive Display

Date: 08/20/2009

Time: 12:33:55

Surface Stats:

Ra: 2.81 μm

Rq: 3.92 μm

Rt: 70.80 μm

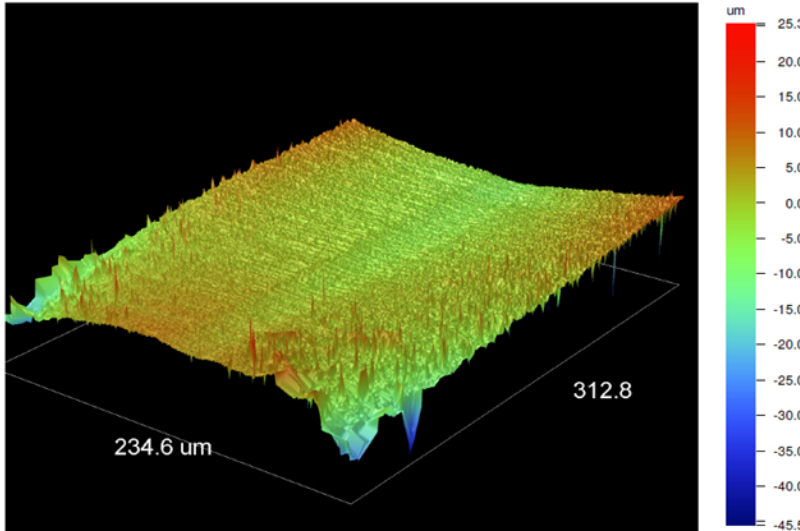
Measurement Info:

Magnification: 20.26

Measurement Mode: VSI

Sampling: 488.69 nm

Array Size: 640 X 480



Title: Cone 2a

Note: Dwell Mark Analysis

Using inspection equipment available within the Laser Target Fabrication Group the depth of this dwell feature was measured to be 2.4 microns .

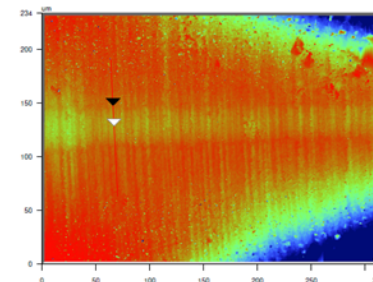
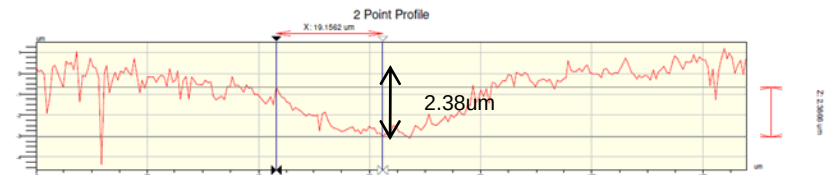


Title: Cone 2a

Date: 08/20/2009

Time: 12:33:55

Note: Dwell Mark Analysis Measurement Mode: VSI Magnification: 20.26



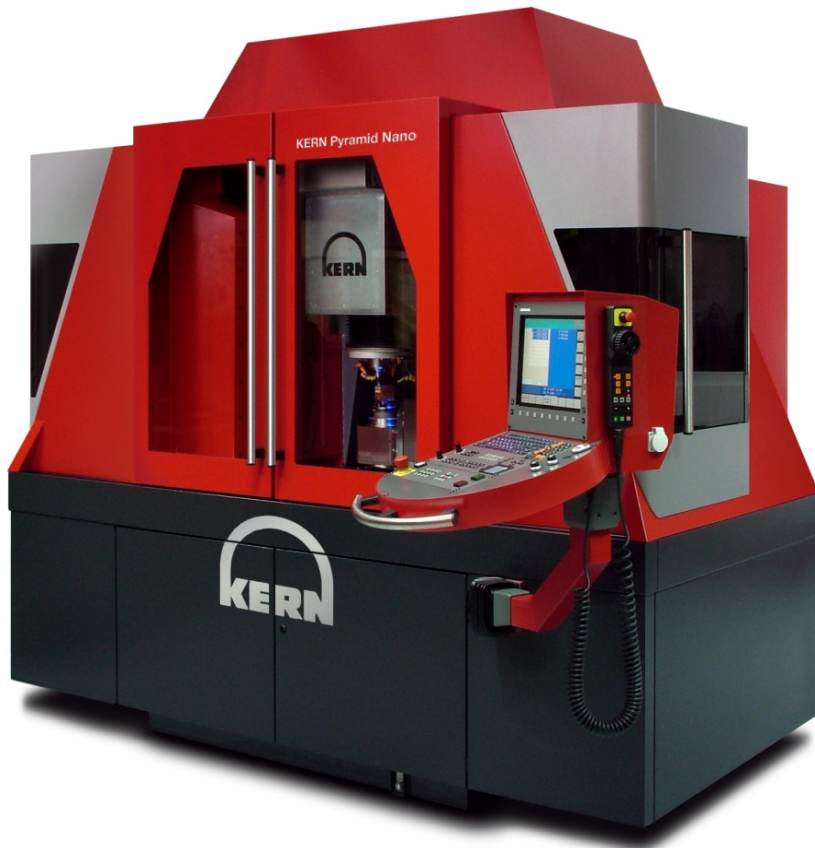
UserNote1:

UserNote2:

UserNote3:

Rq	0.60 μm
Ra	0.52 μm
Rt	2.23 μm
Rp	-0.66 μm
Rv	-2.88 μm

Enhanced development using KERN Pyramid Nano



- To enable mass production large numbers of cones need be machined in a continuous cycle.
- Using bespoke jigs and fixtures this can be extended further by having a number of blocks all set on the machine at the same time.
- In order to manufacture accurate geometries it is important to understand the performance of tooling.

Cutter Strategy development

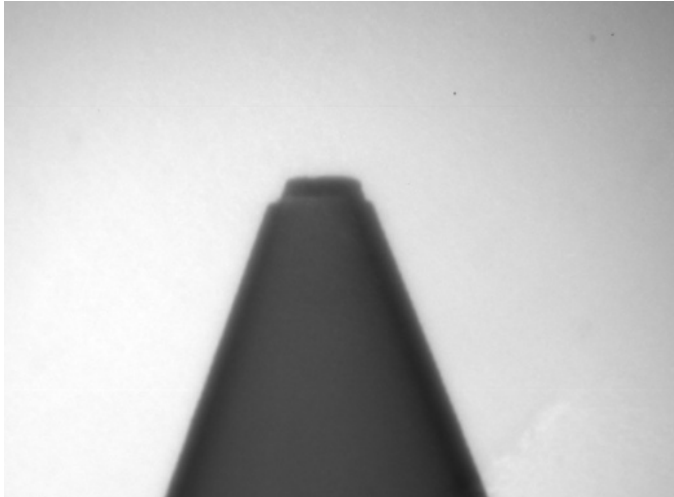
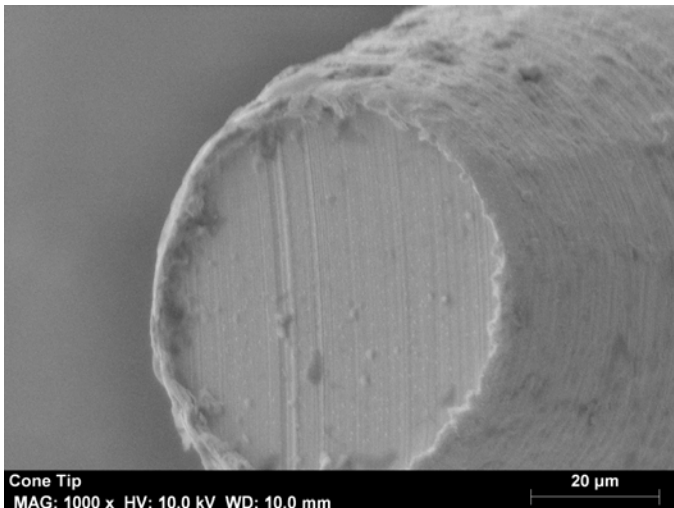


Image courtesy R.Greedharee AWE



Dwell marks removed due to new machine with hydrostatic bearings and developments and refinements to tool paths.

Strategy 1

Machine all the tops to finish size followed by the machining of side walls.

Problems

Resulting cutter wear produces a step at the apex.

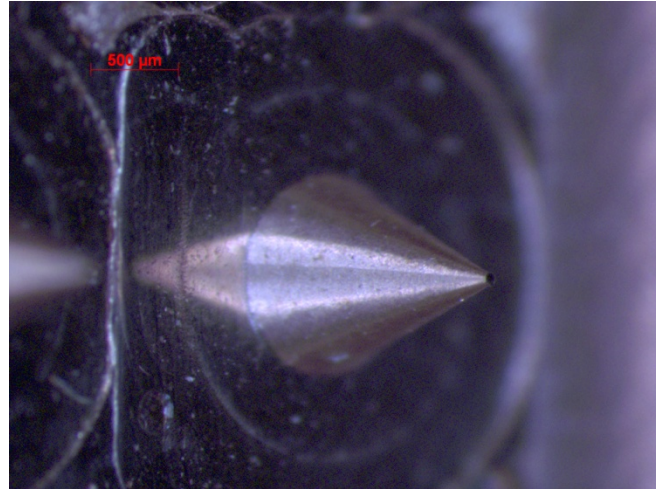
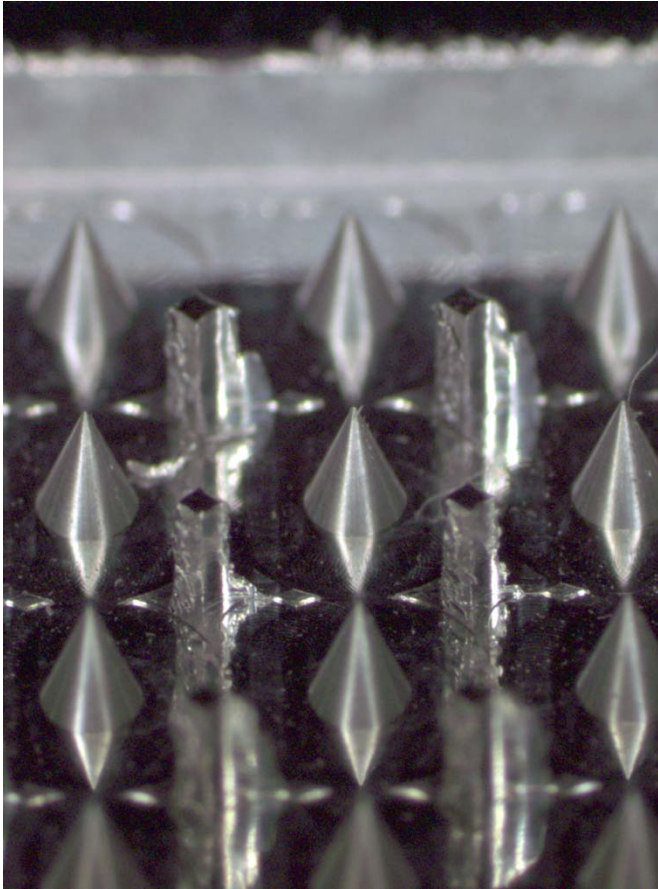
Strategy 2

Machine top surface of cones flat
Followed by machining of sidewalls

Problems

Burring on top face of cone

Mass manufacture



- Using modular jigs and fixtures a single block can be machined featuring ~ 50 cones.
- This is then gold plated and returned to the machine to have the external profile formed.
- The final phase is to etch off the cones.
- Nominally each machining cycle lasts 46hrs.

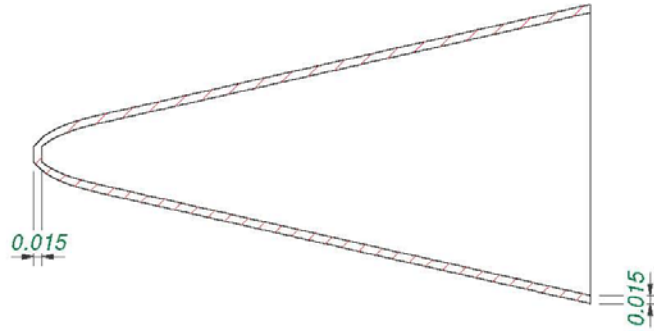
A3 Parabolic Cone

PROJECTION

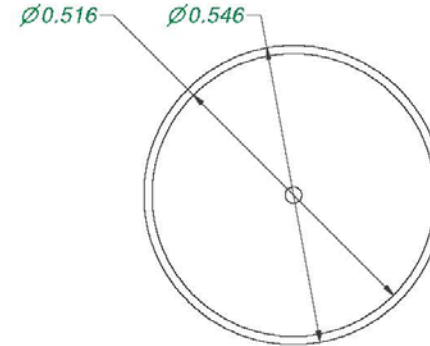
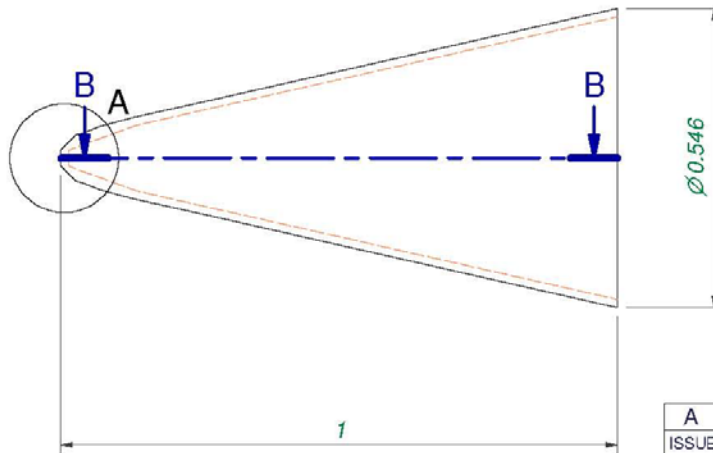
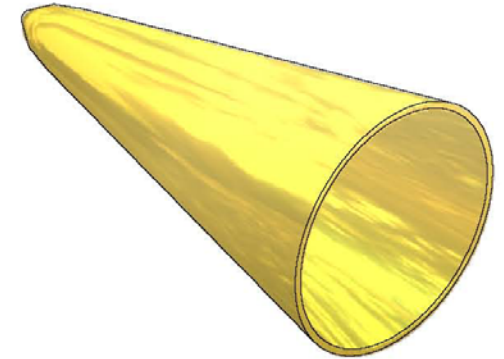
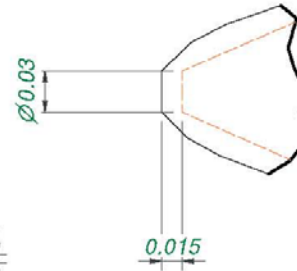


THIS DRAWING CONFORMS TO B.S.8888

B-B (120 : 1)



A (300 : 1)



A3 Parabolic Cone

A	01/04/2009				
ISSUE	DATE	MODIFICATION DESCRIPTION	DRN.	CHKD.	APPD.

USED ON

©STFC 2007

S.T.F.C. - RUTHERFORD APPLETON LAB. OX11-0QX

TITLE

Parabolic Cone LLNL

A3 Parabolic Cone

REV

TOLERANCE UNLESS STATED

± 0.1

FINISH

CLEAN

REMOVE ALL BURRS

SURFACE FINISH μm

1.6

UNLESS STATED

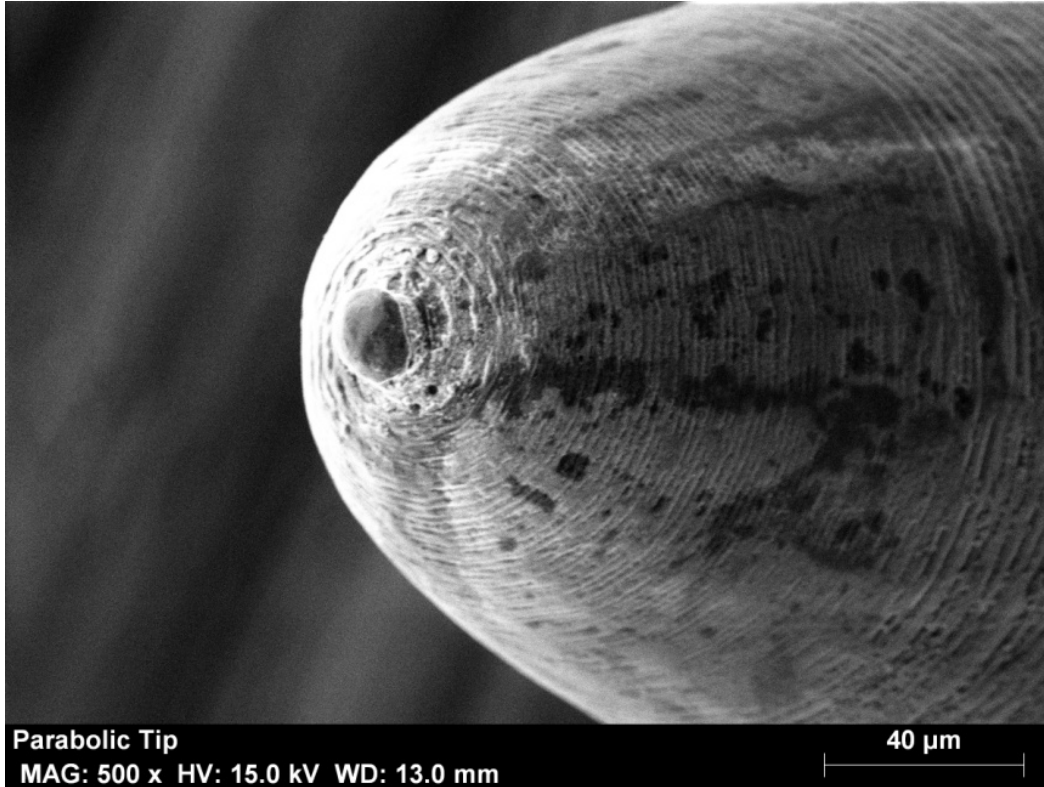
ORIGINAL SCALE

DO NOT SCALE

0

mm

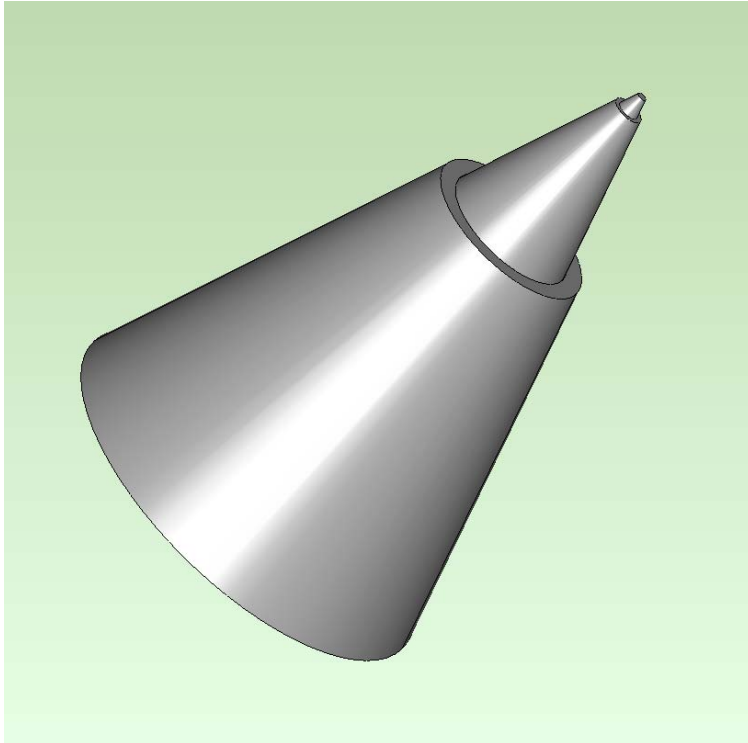
Parabolic Cone development



- The staircase effect is a result of 1 micron step over distances.
- Further down on the sidewalls this is extended to 2 microns.
- Evidence of superb positional accuracy.

Complex parabolic cones use similar machining strategies to earlier designs. It is important that the data is correctly entered into the programme. Here the cutter path just fell short of the central axis of the cone leaving a raised section on the tip.

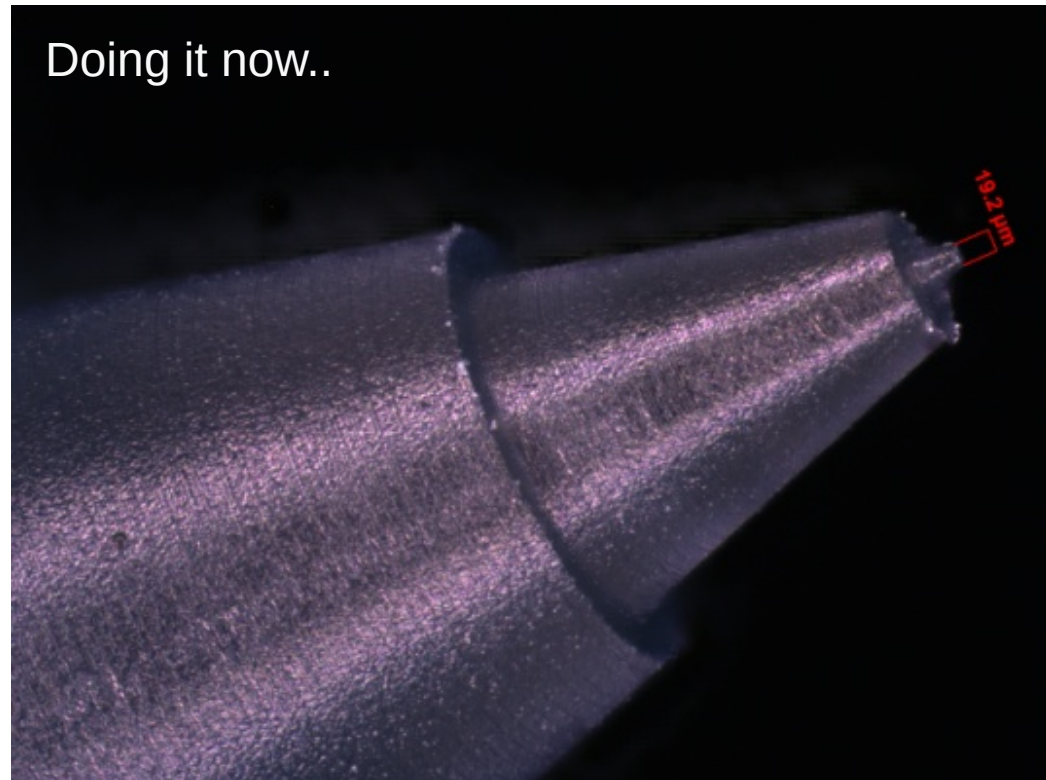
Future exploitation



Modelling of multilayered cones to include features $1/5^{\text{th}}$ the size of a human hair!

Is this even possible?

Doing it now..



Contact Details

- E-mail; mat.beardsley@stfc.ac.uk
- Telephone; 01235 446562

